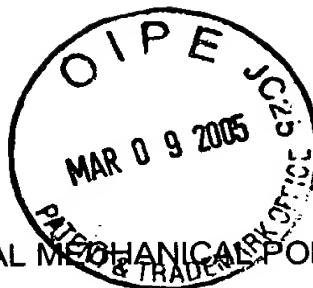


In re Application of: Kazuhiro TANAKA
 Application No. 09/965,803
 Filed: October 1, 2001
 For: METHOD OF CHEMICAL MECHANICAL POLISHING



U.S. Patent and Trademark Office
 Randolph Building
 401 Dulany Street, Customer Window, Mail Stop Amendment
 Alexandria, VA 22314


Sir:

- ☐ Small entity status is claimed for this application under 37 CFR 1.27.
- ☒ Petition for an extension of time for the period noted below, as well as for any additional period necessary to render the present submission timely. Please charge Deposit Account No. 12-1216 for the appropriate petition fee.
- ☐ Other:
- ☒ Please charge Deposit Account No. 12-1216 in the total amount indicated below. A duplicate copy of this transmittal sheet is enclosed herewith.

					SMALL ENTITY		OTHER THAN A SMALL ENTITY	
TIME EXTENSION PETITION FEE		one-month			\$ 0.00			\$120.00
	subtract time extension fee previously paid	none			(\$ 0.00)			(\$ 0.00)
CLAIM FEE	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR	EXTRA CLAIMS PRESENT	RATE	ADD'L CLAIM FEE	RATE	ADD'L CLAIM FEE
TOTAL		MINUS		=	x 25=	\$	x 50=	\$
INDEPENDENT		MINUS		=	x 100=	\$	x 200=	\$
<input type="checkbox"/>	FIRST PRESENTATION OF MULTIPLE CLAIM				+ 180=	\$	+ 360=	\$
TOTAL AMOUNT TO BE CHARGED TO DEPOSIT ACCOUNT					TOTAL	\$	TOTAL	\$120.00

- ☒ The Commissioner is hereby authorized to charge any deficiencies in the following fees associated with this communication or credit any overpayment to Deposit Account No. 12-1216.
- ☒ Any filing fees under 37 CFR 1.16 for the presentation of extra claims.
- ☒ Any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,


 Jeffrey A. Wyand, Reg. No. 29,458
 LEYDIE, VOIT & MAYER
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 Washington, DC 20005-3980
 (202) 737-6770 (telephone)
 (202) 737-6776 (facsimile)

Date:

JAW/tps

Amendment or ROA Transmittal (Revised 1/14/05)

March 9, 2005



EFW 1763
\$

PATENT
Attorney Docket No. 401384

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Kazuhiro TANAKA

Application No. 09/965,803

Art Unit: 1763

Examiner: R. Culbert

Filed: October 1, 2001

For: METHOD OF CHEMICAL
MECHANICAL POLISHING

RESPONSE TO OFFICE ACTION

U.S. Patent and Trademark Office
Randolph Building
401 Dulany Street Customer Window
Alexandria, VA 22314

Dear Sir:

In response to the Office Action dated November 17, 2004, Applicants petition for a one-month extension of time, submit the requisite fee therefore, and request that the referenced patent application be amended as shown below.

03/11/2005 MBEYENE1 00000100 121216 09965803

01 FC:1251 120.00 DA